



IFW
AR

Docket No. 1232-4807

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Tsuneo KANDA

Group Art Unit: 2851

Serial No.: 10/033,081

Examiner: A. Mathews

Filed: December 27, 2001

For: MASK AND PROJECTION EXPOSURE APPARATUS

AMENDMENT AFTER FINAL REJECTION

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Responsive to the Official Action dated May 6, 2004, Applicant respectfully requests reconsideration in view of the following amendments and remarks.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.